

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Hachishiro IIZUKA

SERIAL NO: 10/565,676

GAU: 1792

FILED: January 24, 2006

EXAMINER: Keath T. Chen

FOR: GAS REACTION SYSTEM AND SEMICONDUCTOR PROCESSING APPARATUS

**REQUEST FOR EXTENSION OF TIME  
UNDER 37 C.F.R. 1.136**

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

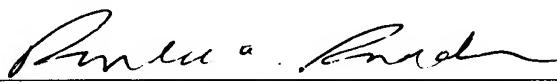
It is hereby requested that a **one** month extension of time be granted to March 9, 2008 for

- filing a response to the Official Action dated:
- responding to the requirements in the Notice of Allowability dated:
- filing the Formal Drawings. The Issue Fee due has been timely filed.
- responding to the Notice to File Missing Parts of Application dated:
- filing a Request for Continued Examination (RCE). A timely response to the final rejection, due February 9, 2008 has been filed.
- filing an Appeal Brief. A Notice of Appeal was filed on:
- Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$120.00 is being made by credit card payment and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.



Steven P. Weihrouch

Registration No. 32,829

Customer Number

**22850**

Tel. (703) 413-3000  
Fax. (703) 413-2220  
(OSMMN 05/03)

I:\ATTY\RARI RCE\284901US\PETITION FOR EXTENSION OF TIME 3-9-08.DOC

Ronald A. Rudder, Ph.D.  
Registration No. 45,618